Short Pre	esentation (Poster) 1 March 7 (MON) 19:00~20:00
07P-01	3-Dimensional Plasma Actuator for Flowing Gas Containing Reactive Species Mao Xu, Motoaki Yamauchi and Akitoshi Okino Tokyo Institite of Technology
07P-02	Study on CO Gas Sensing by Sputtering Different Power ZnO Films Yi-Zhe Zhang and Yen-Sheng Lin I-Shou University
07P-03	Sputtering Process of Porous Gallium-Doped Zinc Oxide Thin Film to Apply on CO Gas Sensing Yu-Meng Taso and Yen-Sheng Lin ¹ I-Shou University
07P-04	Study on Improving the Optical and Electrical Properties of ZnO Thin Films by Intermittent Sputtering Process Shih-Cheng Tseng and Yen-Sheng Lin I-Shou University
07P-05	The Characterization of VO2 Deposited by High-Power Impluse Magnetron Sputtering for MIS Applications ¹ Pin-Syun Jiang, ² Chien-Chieh Lee and ¹ Pi-Chun Juan ¹ Ming Chi University of Technology ² National Central University
07P-07	The Influence of Pulse-Modulation on OH Radical Generation from Non-Thermal Atmospheric-Pressure Plasma Yi-Wei Wang and Yun-Chien Cheng National Chiao Tung University
07P-08	Study of the Influence of Deformation Structures on the Sensitivity of AZO Thin Film Sensor. Yung-Cheng Wei and Yen-Sheng Lin I-Shou University
07P-09	Heating of Siliver Nanoparticles in the Gas Phase by Ar/H ₂ Surface Wave Pasma ¹ Kazuya Hikita, ¹ Kensuke Sasai, ^{1,2} Haruka Suzuki and ^{1,2,3} Hirotaka Toyoda ¹ Nagoya University ² Center for low-temperature Plasma Sciences, Nagoya University ³ National Institute of Fusion Science
07P-10	A Study of Potential Risk and Improvement of APS YF3 Coating on ICP Source Youngjae Ma, Jongwoo Park, Hyojeong Seo, BeomSeok Kim and Sung Jin Yoon PSK inc.
07P-11	Multi-Signal Monitoring for Discharge Optimization in Linear Plasma Device

NAGDIS-II

Noriyasu Ohno Nagoya University

Takehiro Sakakibara, Hiroki Natsume, Yohei Imaeda, Hirohiko Tanaka, Shin Kajita and

O7P-13 Suppression of Arc Ignition on Nano-Tendril Bundles by Annealing Treatment

¹Rongshi Zhang, ¹Shin Kajita, ²Dogyun Hwangbo, ³Dmitry Sinelnikov, ¹Hirohiko Tanaka and

¹Noriyasu Ohno

¹Nagoya University

²University of Tsukuba

³Nation Research Nuclear University MEPhI

07P-14 RF Voltage Division of in RF-Biased High-Density Plasma with Floating Liner

¹Yukinori Chiba, ¹Manabu Kyuzo, ^{1,2}Haruka Suzuki and ^{1,2,3}Hirotaka Toyoda

¹Department of Electronics, Nagoya University

²Center for Low-temperature Plasma Sciences, Nagoya University

³National Institute for Fusion Science

07P-15 Study on Improving Touch Sensitivity by Inserting CuO Nanostructure

Jia-Jun Liu and Yen-Sheng Lin

I-Shou University

07P-17 Trial of Elemental Gradient Functional Thin Films Preparation by Sputtering with

Mixed Powder Targets I

Hiroharu Kawasaki, Tamiko Ohshima, Yoshihito Yagyu, Takeshi Ihara and Takahiko Satake National Institute of Technology, Sasebo College

07P-20 Study of the Deformation Influence on Ga-Doped ZnO Thin Film Touch Sensor

Ping-Tai Jiang, Yan-Jun Wang and Yen-Sheng Lin

I-Shou University

07P-22 Spectral Reflectance Analysis of the Formation State of a Titanium Thin Film

Deposited on a Plastic Substrate by DC Magnetron Plasma Sputtering

¹Akira Watazu, ²Yoshihiro Nishimura, ¹Kay Teraoka, ²Masanobu Tobe, ²Ryo Kobori and

¹Tsutomu Sonoda

¹National Institute of Advanced Industrial Science and Technology (AIST)

²Lasertec Corporation

07P-23 Hydrogen Entry State of Coating Material Using Sputtering Method

Yuya Muramoto, Hiroshi Nishiguchi, Ohshima Tamiko and Kawasaki Hiroharu

National Institute of Technology, Sasebo College

07P-26 Development of Planar Plasma Source for Metal Organic Plasma Decomposition

¹Hiroshi Akamatsu and ²Kazunori Ichikawa

¹Kobe City College of Technology

²National Institute of Technology, Matsue College

07P-27 Effect of Ion Shielding on Sulfur Defect Formation in Monolayer MoS₂ Treated by

Microwave Hydrogen Plasma

Akihisa Ogino and Shuya Asada

Shizuoka University

O7P-28 Deposition of TiO₂ Film on Resin Substrate by Atmospheric Solution Precursor Plasma Spraying Using Air Working Gas

¹Xi Wang, ¹Boyu Zhang, ¹Tianshuo Wang, ¹Fengzhi Wu, ¹Yasutaka Ando and ²³Akira Kobayashi

¹Ashikaga University

²Chulalongkorn University

³The University of Tokyo

O7P-29 Al-Doped Zinc Oxide Thin Films Deposition with Mixed Powder Targets by Sputtering

^{1,2}Tamiko Ohshima, ¹Yusuke Hibino, ¹Takeshi Ihara, ¹Yoshihito Yagyu, ^{1,3}Takahiko Satake, ¹Hiroharu Kawasaki, ²Naho Itagaki, ²Kazunori Koga and ²Masaharu Shiratani

¹National Institute of Technology, Sasebo College

²Kyushu University

³Sojo University

07P-30 Emission Spectra and Raman Spectral Studies of TiCN Thin Films Deposited Using a Magnetized Sheet Plasma Source.

^{1,2}Glenson Panghulan, ²Christlyn Faith Arias, ²Ryan Russel Gabatino, ²Catherine Joy Dela Cruz, ²Kenneth Duque and ²Magdaleno Jr Vasquez

¹University of the Philippines

²University of the Philippines-Diliman

O7P-31 Structural Analysis of Topmost Surface of a-C:H film by Using Surface-Enhanced Raman Spectroscopy

¹Ryosei Iwai, ¹Hiroyuki Kousaka, ²Takayuki Tokoroyama, ²³Yuya Nakasima, ¹Tatsuya Furuki and ²Noritsugu Umehara

¹Gifu University

²Nagoya University

³Fuji Electric Co., LTD.

O7P-32 Preparation of Electron Transport Layer for Perovskite Solar Cells by Microwave Plasma Treatment on Sputtered Tin Thin Films

Po-Jui Hsu and Meng-Jiy Wang

National Taiwan University of Science and Technology

07P-33 Deposition of PFCs Films on Die with Microstructures Using CF₄ Gas

Gang Han, Masaya Watanabe, Seiya Fujita and Minoru Sasaki

Toyota Technological Institute

07P-34 Relationship between Discharge Characteristics and Film Density in DLC Film Deposition Using HF-HiPIMS Method

¹Hiroyuki Fukue, ¹Tatsuyuki Nakatani, ²Tadayuki Okano, ²Masahide Kuroiwa, ³Shinsuke Kunitsugu, ⁴Hiroki Oota and ^{1,4}Ken Yonezawa

¹Okayama University of Science

²Tokyo Electronics Co., Ltd.

³Industrial Technology Center of Okayama Prefecture

⁴Kenix Corporation

Short Presentation (Poster) 2

March 8 (TUE) 13:30~14:30

08P-01 Generation and Characterization of Spiral Hydrogen-Nitrogen Mixed Plasmas for Ammonia Synthesis

Kota Hiraiwa, Noriyasu Ohno, Keigo Tojo, Ryosuke Nishio, Shin Kajita and Hirohiko Tanaka Nagoya University

08P-02 Development and Optimization of Cascaded Arc Plasma Source in TPD-II

¹Yuki Hayashi, ^{1,2}Yukinori Hamaji, ¹Suguru Masuzaki, ³Naomichi Ezumi, ⁴Noriyasu Ohno,

⁵Shinichi Namba and ⁴Makoto Takagi

¹National Institute for Fusion Science

²SOKENDAI

³University of Tsukuba

⁴Nagoya University

⁵Hiroshima University

08P-03 Multi-Elements Mixture Thin Film Preparation Process by Sputtering Deposition Using Mixture Powder Target I

^{1,2}Takahiko Satake, ¹Tamiko Ohshima, ¹Yoshihito Yagyu, ¹Takeshi Ihara, ¹Hiroharu Kawasaki and ²Sin-ichi Aoqui

¹National Institute of Technology, Sasebo College

²Sojo University

08P-04 Development of Ultra-Highly Oriented Aluminum Nitride Thin Films by Pressure Gradient Sputtering Method

¹Ken Yonezawa, ¹Hiroki Ohta, ¹Susumu Yonezawa, ²Tatsuyuki Nakatani, ³Masaharu Shiratani,

³Kazunori Koga and ⁴Jun-Seok Oh

¹Kenix Corporation

²Okayama University of Science

³Kvushu University

⁴Osaka City University

08P-05 Effect of Substrate Temperature on Morphology of Carbon Nanowalls Grown by a Radical-Injection Plasma-Enhanced Chemical Vapor Deposition Using C₂F₆/H₂ Mixture Gas

¹Takumi Hashimoto, ²Hiroki Kondo, ²Kenji Ishikawa, ²Takayoshi Tsutsumi, ²Makoto Sekine,

³Mineo Hiramatsu and ²Masaru Hori

¹Nagoya University

²Center for Low-temperature Plasma Sciences

³Meijo University

08P-06 Directional Material Probe for Analyzing of Directionalities in Deposition Layers

Suguru Masuzaki

National Institute for Fusion Science

O8P-07 Study on Using Mixed Powder Target for Transparent Conductive Thin Film Preparation by Sputtering Method

^{1,2}Takahiko Satake, ¹Tamiko Ohshima, ¹Yoshihito Yagyu, ¹Takeshi Ihara, ¹Hiroharu Kawasaki and ²Sin-ichi Aoqui

¹National Institute of Technology, Sasebo College

²Sojo University

O8P-08 Plasma Enhanced Chemical Vapor Deposition of Carbon Nanowalls with Negative DC Bias Application

Koki Takeuchi, Keigo Takeda and Mineo Hiramatsu

Meijo University

08P-09 Initial Growth of Graphene Using Microwave-Excited Non-Equilibrium Atmospheric

Pressure Remote Plasma Enhanced Chemical Vapor Deposition

Yusuke Sakai, Kajino Akihiro, Keigo Takeda and Mineo Hiramatsu

Meijo University

08P-10 Formation of Diamond-Like Carbon Film on Organic Substrate by High Power

Impulse Magnetron Sputtering

¹Takayuki Ohta, ²Akinori Oda and ³Hiroyuki Kousaka

¹Meijo University

²Chiba Institute of Technology

³Gifu University

08P-11 Effect of Average Power Density on Deposition of Diamond-Like Carbon Using High

Power Impulse Magnetron Sputtering

¹Sota Okumura, ¹Jo Matsushima, ²Akinori Oda, ³Hiroyuki Kousaka and ¹Takayuki Ohta

¹Meijo University

²Chiba Institute of Technology

³Gifu University

08P-12 Atmospheric Pressure Plasma Diagnostics Using an Ion Mobility Spectrometer

Keith Nealson Penado and Motoi Wada

Doshisha University

08P-13 Laser-Induced Fluorescence Spectrum Measurement Using Optical Vortex Beams

¹Shinji Yoshimura, ²Kenichiro Terasaka and ³Mitsutoshi Aramaki

¹National Institute for Fusion Science

²Kyushu University ³Nihon University

Radical Measurement of Ar/C₄F₈ Dual Frequency Capacitively-Coupled Plasma

¹Yuto Seki, ¹Haruhito Kato, ¹Schuichi Kuboi, ¹²Haruka Suzuki and ^{1,2,3}Hirotaka Toyoda

¹Nagova University

²Center for Low-temperature Plasma Sciences

³National Institute for Fusion Science

08P-16 Finite Temperature Effect on Kinetic Monte-Carlo Simulation Applied to Tungsten

Surface Diffusion

^{1,2}Atsushi Ito and ^{1,2}Arimichi Takayama

¹National Institute for Fusion Science

²The Graduate University for Advanced Studies (SOKENDAI)

08P-17 Molecular Dynamics Simulation of Vacancy Cluster Formation and Hydrogen Isotope Trapping in Neutron Irradiated Tungsten

¹Miyuki Yajima, ²Seiki Saito, ³Kazuki Takasan, ^{1,3}Hiroaki Nakamura and ^{1,4}Daiji Kato

¹National Institute for Fusion Science

²Yamagata University

³Nagoya University

⁴Kyushu University

08P-18 Migration Energy Related to Tungsten Surface Diffusion Evaluated by Ab Initio Calculation

^{1,2}Arimichi Takayama and ^{1,2}Atsushi Ito

¹National Institute for Fusion Science

²The Graduate University for Advanced Studies, SOKENDAI

OES Measurement of Diaphragm Discharge: Investigation into Electron and Gas Temperature

Taichi Watanabe, Nozomi Takeuchi and Shungo Zen

Tokyo Institite of Technology

08P-20 Visualization of Reactive Oxygen Species Distribution around Argon Plasma Jet with Chemical Probe

¹Trung Nguyen Tran, ¹Min Hu, ¹Ryoko Asada, ²Jin Sakamoto And ¹Hiroto Matsuura

¹Osaka Prefecture University

²Kansai University

08P-21 Bubbling Phenomenon of Sn-Bi-Li-Er Alloy under H2 Plasma Exposure

¹Kota Tamura, ^{1,2}Haruka Suzuki, ³Junichi Miyazawa, ³Suguru Masuzaki, ³Masayuki Tokitani and

1,2,3Hirotaka Toyoda

¹Nagova University

²Center for Low-temperature Plasma Sciences, Nagoya University

³National Institute for Fusion Science

08P-22 Development of a New Bonding Process for a Plastic-to-Metal Joining by Using a

High-Frequency Plasma Jet

¹Giichiro Uchida, ²Kosuke Takenaka and ²Yuichi Setsuhara

¹Meijo University

²Osaka University

08P-23 Significant Wear-Resistance Improvement of Polyimide Composite with Small Amount

of Plasma-Treated Carbon Nanotubes

Daisuke Ogawa and Keiji Nakamura

Chubu University

08P-24 Tuning Plasma-Knobs to Control Seamless Radical-Induced Biological Reaction

Processes

Masaru Hori, Hiromasa Tanaka and Kenji Ishikawa

Nagoya University

08P-25 Low Temperature Plasma Chemistry of Volatile and Non-Volatile Solutes in Aqueous

Solutions: e.p.r. and Spin Trapping Studies

^{1,3}Hidefumi Uchiyama, ²Kenji Ishikawa, ²Masaru Hori and ³Takashi Kondo

¹Tateyama Machine Co. Ltd.

²Nagova University

³University of Toyama

08P-26 Uniformity of the Introduction of Substances into Cells by Plasma at the Micro Air-

Liquid Interface

Yuki Tsutsui, Motonari Suzuki and Shinya Kumagai

Meijo University

08P-27 Study on Dielectric Barrier Discharge Plasma Irradiation Conditions for the

Measurement of Active Species Passing through Lipid Bilayers.

Yuto Ando and Shinya Kumagai

Meijo University

08P-28 Biocompatibility of Conformal Coating of SiC on Carbon Nanowall Scaffold

¹Koki Ono, ¹Takashi Koide, ²Kenji Ishikawa, ²Hiromasa Tanaka, ²Hiroki Kondo, ²Ayae Sugawara-

Narutaki, ³Yong Jin, ³Shigeo Yasuhara, ²Masaru Hori and ¹Wakana Takeuchi

¹Aichi Institute Technology

²Nagoya University

³Japan Advanced Chemicals Ltd.

08P-29 Improvement of Efficiency of Biodegradation of Polyethylene Terephthalate Using

Neutral-Oxygen-Radical Source

¹Daichi Goto, ¹Naoyuki Iwata, ¹Kenji Ishikawa, ¹Hiroshi Hashizume, ¹Hiromasa Tanaka,

²Masafumi Ito and ¹Masaru Hori

¹Nagoya University ²Meijo University

08P-30 Effect of Cold Plasma Treatment on the Paramagnetic Species of Seed Coats

¹Pankaj Attri, ¹Takamasa Okumura, ^{1,2}Kazunori Koga and ¹Masaharu Shiratani

¹Kvushu University

²Center for Novel Science Initiatives, National Institute of Natural Science, Tokyo, Japan

08P-31 Growth-Promotion Effect of Oxygen-Radical-Treated Tryptophan Solutions on

Arabidopsis Thaliana

¹Shota Araki, ¹Tomomiti Ota, ¹Hironaka Tsukagoshi, ²Naoyuki Iwata, ²Masaru Hori and

¹Masafumi Ito

¹Meijo University

²Nagoya University

08P-32 Analysis of Cells Directly Irradiated with Cold Atmospheric Pressure Plasma

Yuki Ogawa, Motonari Suzuki, Masafumi Ito and Shinya Kumagai

Meijo University

Short Presentation (Poster) 3

March 8 (TUE) 19:00~20:00

08P-34 Effect of Atmospheric Pressure Nitrogen Plasma Assistance on Mist CVD of Zinc Oxide Thin Films

Hiroya Kobayashi, Keigo Takeda and Mineo Hiramatsu

Meijo University

08P-35 Two Photon Laser Induced Fluorescence to Measure Nitrogen Atomic Density in NAGDIS-T

¹Shin Kajita, ¹Ryosuke Nishio, ¹Hirohiko Tanaka, ¹Keigo Tojo, ¹Kota Hiraiwa, ²Ryo Yasuhara,

³Mitsutoshi Aramaki and ¹Noriyasu Ohno

¹Nagova University

²National Institute for Fusion Science

³Nihon University

08P-36 Optical Wave Microphone Measurement of Pressure Waves Generated during Plasma

Formation

¹Masahiro Kamasaki, ¹Khing Zaw Phyo, ²Toshiyuki Kawasaki and ¹Fumiaki Mitsugi

¹Kumamoto University

²Nishinippon Institute of Technology

O8P-38 Optical Wave Microphone Measurement of Sound Waves Generated from a Surface Discharge Driven by a High Voltage Pulse

¹Daichi Suemoto, ²Yoshito Sonoda, ²Toshiyuki Nakamiya and ¹Fumiaki Mitsugi

¹Kumamoto University

²Shin-Giken Co., Ltd.

O8P-39 Detection of Sound Arrival Direction Using Optical Wave Microphone for Application of Plasma Diagnostics

¹Asuka Uto, ¹Fumiaki Mitsugi, ²Toshiyuki Nakamiya and ²Yoshito Sonoda

¹Kumamoto University ²Shin-Giken Co., Ltd.

08P-40 Effect of Gouy Phase Shift on Optical Vortex Laser Absorption Spectroscopy

¹Hiroki Minagawa, ²Hirokazu Kobayashi, ³Shinji Yoshimura, ⁴Kenichiro Terasaka and ¹Mitsutoshi

Aramaki

¹Nihon University

²Kochi University of Technology

³National Institute for Fusion Science

⁴Kyushu University

08P-41 Study for Densification and Stabilization of Hydrogen-Isotope Plasma in NAGDIS-II

Imaeda Yohei, Sakakibara Takehiro, Natsume Hiroki, Tanaka Hirohiko, Kajita Shin and Ohno

Noriyasu

Nagoya University

O8P-42 Thermal Atomic Layer Etching of Cobalt with Plasma Chlorination and Ligand Volatilization

Yongjae Kim, Hojin Kang, Hyungwoo Lee, Heeju Ha and Heeyeop Chae

Sungkyunkwan University

Oxide Etch Process Design for Particle Contamination Reduction in Plasma-Etching Equipment

Chingming Ku and Stone Cheng National Chiao Tung University

08P-44 Effect of Air Introduction between Electrodes on Rapid Removal Process of Polymer Contamination on Floor by Atmospheric Pressure Plasma

¹Yoshihiro Sakamoto, ²Takayoshi Tsutsumi and ²Masaru Hori

¹panasonic co.,Ltd ²Nagoya University

O8P-45 Prediction of the Relaxation of a Polyethylene Damaged by Substituted Tritium Based on the Linear Response Theory

^{1,2}Ryuta Kawanami, ¹Susumu Fujiwara, ^{3,4}Hiroaki Nakamura and ^{5,6}Kazumi Omata

¹Kyoto Institute of Technology

²Kansai Photon Science Institute

³National Institute for Fusion Science

⁴Nagoya University

⁵National Center for Global Health and Medicine

⁶Kumamoto University

08P-46 Optical Vortex Propagation Simulation in Corrugated Waveguide

¹Yoshihisa Fujita, ^{2,3}Hiroaki Nakamura, ⁴Hideki Kawaguchi, ⁵Shin Kubo and ²Yuki Goto

¹Ritsumeikan University

²National Institute for Fusion Science

³Nagoya University

⁴Muroran Institute of Technology

⁵Chubu University

08P-47 Long Term Synthesis of Silver Nanoparticles Using a Liquid-Flow Plasma Device

¹Kazuya Yamaguchi, ^{1,2}Haruka Suzuki, ²Kensuke Sasai and ^{1,2,3}Hirotaka Toyoda

¹Department of Electronics, Nagoya University

²Center for Low-temperature Plasma Science, Nagoya University

³National Institute of Fusion Science

08P-48 Effect of Atmospheric Pressure Plasma on Chitosan-Acrylic Acid Blends

Kathrina Lois Taaca, Mark Jeffry De Leon, Eloise Prieto and Magdaleno Vasquez Jr

University of the Philippines-Diliman

08P-51 Synthesis of β-FeSi₂ by Molten Salt Method

Ye Li, Yosuke Shimura and Hirokazu Tatsuoka

Shizuoka University

O8P-52 Controllable Fabrication of Au-Nanoprotrusion Arrays as a Substrate for the Cross-Sectional Transmission Electron Microscopy Characterization

¹Wei Ming Lin, ¹Shinsuke Ozeki, ¹Takumi Yoshida, ¹Kento Oyama, ²Tatsuya Akiyama, ³Yazid

Yaakob, ¹Toru Asaka, ¹Noriyuki Sonoyama and ¹Masaki Tanemura

¹Nagoya Institute of Technology

²F.C.C. Co.Ltd

³Universiti Putra Malaysia

08P-53 Glucose Oxidase Modification of Nanographene Materials Synthesized by In-Liquid

Issei Kuzumi, Keigo Takeda and Mineo Hiramatsu

Meijo University

08P-55 The Electrical Characterization and Interfacial Property of α- and β-MoO₃ by

Plasma-Enhanced Atomic Layer Deposition on Silicon Substrate

Yi-Hui Juan and Chien-Chieh Lee

National Central University

08P-56 Phonon Transport in Thin Si Layers with Surface Roughness Controlled by

Atmospheric Plasma Treatment

¹Hiroya Ikeda, ¹Arashi Yamaguchi, ¹Ryota Kasagi, ¹Yuto Kato, ²Khotimatul Fauziah, ¹Yukinori Ono and ¹Akihisa Ogino

¹Shizuoka University

²Agency for the Assessment and Application of Technology

08P-57 Change in Properties of NiO Films by Thermal Annealing

Ryuya Ito, Yuto Ebata, Tomoyuki Suzuki, Shigeru Yamada and Takashi Itoh

Gifu University

08P-60 Design of Wideband CMOS Biosensor with Active-Inductor-Based VCO for Detecting

CTCs and Exosomes

Takuya Tsujimura, Guowei Chen, Yuma Hayashi, Sora Kato and Kiichi Niitsu

Nagoya University

08P-61 Preparation of Conductive Silver Electrodes by Microplasma Direct Printing for

Biosensing Applications

Zhe-Ming Hsu and Meng-Jiy Wang

National Taiwan University of Science and Technology

08P-62 Study of the Effect of Plasma-Activated Water Generated by Different Sources on

Ca²⁺ Signalling in Arabidopsis Thaliana

¹Vanni antoni, ²Enrico Cortese, ³Luca Cappellin, ⁴Manuele Dabalà, ¹Alessandro Fassina, ⁵Alessia Famengo, ⁵Alessandro Galenda, ⁴Alessio G. Settimi and ²⁶Lorella Navazio

¹Consorzio RFX

²Department of Biology, University of Padova, Italy

³Department of Chemical Sciences, University of Padova, Italy

⁴Department of Industrial Engineering, University of Padova, Italy

⁵CNR Institute of Condensed Matter Chemistry and Technologies for Energy (ICMATE), Padova, Italy

⁶Botanical Garden, University of Padova, Italy

08P-63 Enhanced Bioremediation of 4-Chlorophenol by Oxygen Radical Treatment Based on

Non-Thermal Atmospheric Pressure Plasma

¹Hiroyuki Kato, ¹Kiyota Sakai, ¹Shou Ito, ²Naoyuki Iwata, ¹Masafumi Ito, ²Masaru Hori, ¹Motoyuki

Shimizu and ¹Masashi Kato

¹Meijo University

²Nagova University

08P-64 Effect of Atmospheric Pressure Non-Thermal Plasma Treatment on Enhancement of

Plant Growth

Norrawit Tonmitr and Akira Yonesu

University of the Ryukyus

08P-65 Absorbance and Nutrient Measurement of Filtrate Prepared from Ozonated Soil

¹Yuto Nomaguchi, ²Mai Kai Suan Tial and ¹Fumiaki Mitsugi

¹Kumamoto University

²Yangon technological University

08P-66 Improvement of Degradation Rate of Carboxymethyl Cellulose Using Ambient-Air Glow Discharge

¹Kazuma Okamoto, ²Hu Xin, ¹Masahiro Maebayashi, ¹Motoyuki Shimizu, ¹Masashi Kato and

¹Masahumi Ito

¹Meijo University

²Nagoya University

Short Presentation (Poster) 4

March 9 (WED) 19:00~20:00

O9P-01 The role of Oxygen Vacancy on Thermochromic Transition of W-Doped VO₂ Films Explained by Current-Variable Hall Technique

¹Ding-Yeong Wang and ²Pi-Chun Juan

¹Feng Chia University

²Ming Chi University of Technology

09P-02 Etching of a Layer from Stacked Graphene in Remote Oxygen Plasma

Liugang Hu, Kenji Ishikawa, Thi-Thuy-Nga Nguyen, Shih-Nan Hsiao, Hiroki Kondo, Makoto Sekine and Masaru Hori

Nagova University

O9P-03 A Two-Dimensional Molecular Dynamics Simulation Study of Titanium Nitride Deposition in Micro-Trenches

^{1,2}Catherine Joy Dela Cruz, ^{2,3}Glenson R. Panghulan, ²Kenneth R. Duque and ²Magdaleno R. Vasquez, Ir

¹Ateneo de Manila University

²University of the Philippines-Diliman

³University of the Philippines

09P-05 Fabrication and Evaluation of N-Polar AlGaN/AlN High Electron Mobility Transistor

¹Wataru Matsumura, ¹Kazuya Ataka, ¹Lu You, ¹Shunsuke Matsuda, ¹Koki Hanasaku, ¹Daisuke Inahara, ²Yongzhao Yao, ²Yukari Ishikawa, ¹Narihito Okada, ¹Satoshi Kurai, ¹Yoichi Yamada and ¹Kazuyuki Tadatomo

¹Yamaguchi University

²Japan Fine Ceramics Center

09P-06 Characterization of Green-Red Emissions from {11-22} Semipolar Multiple Quantum Wells on Fully Relaxed InGaN Underlayer

Yuya Tawarazako, Naoya Nishi, Nakata Atsuto, Shunsuke Tanigawa, Narihito Okada, Satoshi Kurai, Yoichi Yamada and Kazuyuki Tadatomo

Yamaguchi University

09P-07 Fabrication of Extended Absorption ($(CH_3NH_3)_{1-x}Cs_x$) $_3Bi_2I_9$ (x=0-1) Hybrid-Perovskite Solar Cells (HPeSC's) via Hot Immersion Method

^{1,2}Mohd Faizal Bin Achoi, ¹Shunsuke Aiba, ¹Shinya Kato, ¹Naoki Kishi and ¹Tetsuo Soga

¹Nagoya Institute of Technology

²Universiti Teknologi MARA, Cawangan Sabah, Kampus Kota Kinabalu, Sabah 88997, Malaysia

09P-11 Formation and Characterization of Titanium Nitride by Using a Torus-Type Device NAGDIS-T

Keigo Tojo, Noriyasu Ohno, Shin Kajita, Hirohiko Tanaka and Ryosuke Nishio Nagoya University

09P-12 Suppression of Ga Diffusion by Interfacial Barrier Layer in AlSiO/p-GaN

¹Xiaoyu Tian, ¹Wang Liu, ¹Akio Ohta, ¹Noriyuki Taoka, ¹Katsunori Makihara, ²Tetsuo Narita, ²Kenji Ito, ²Keita Kataoka, ²Shiro Iwasaki, ²Daigo Kikuta, ¹Kazuyoshi Tomita and ¹Seiichi Miyazaki

¹Nagoya University

²Toyota Central R&D Labs., Inc.

09P-13 Photoemission Study of Mg Doped GaN(0001) Surfaces

Wang Liu, Xiaoyu Tian, Akio Ohta, Noriyuki Taoka, Katsunori Makihara and Seiichi Miyazaki Nagoya University

09P-14 Photo-Assisted C-V Measurement of p-GaN MOS Diodes

Yuya Tamamura, Takahide Nukariya and Masamichi Akazawa

Hokkaido University

09P-15 Growth of Ultra-Thin GaN/AlN Superlattice Structure toward Deep-UV Emission

¹Naoya Mokutani, ¹Yuichi Wada, ¹Shinichiro Mouri, ²Kanako Shojiki, ²Shiyu Xiao, ²Hideto Miyake and ¹Tsutomu Araki

¹Ritsumeikan University

²Mie University

09P-16 Effect of a Thin AlN Layer Inserted into the GaN Drift Layers on Reverse

Breakdown Behavior for Fully Vertical GaN-on-Si Schottky Barrier Diodes

Akira Mase, Pradip Dalapati, Toshiharu Kubo, Makoto Miyoshi and Takashi Egawa Nagoya Institute of Technology

09P-19 Formation of Carbon Nanotube Yarns by Gas Discharge Breakdown Using Multi-

Electrode Configuration

Hiro Hayama and Hideki Sato

Mie University

09P-20 Measurements of Gas Mixing Ratio by Gas Discharge Breakdown Using Electrode

with Carbon Nanotubes

Kohei Yamamoto and Hideki Sato

Mie University

09P-22 Capping Effect by Surfactant Addition for in Microwave-Assisted Nanoparticle

Synthesis Process

Takahiro Takai, Atsuya Shibatani and Yusuke Asakuma

University of Hyogo

09P-23 Formation Process of Large-Scale Fiberform Nanostructures on a Tungsten Mesh in

Co-Deposition Environment of Helium Plasma and Tungsten

Kenta Hori, Shin Kajita, Rongshi Zhang, Hirohiko Tanaka and Noriyasu Ohno

Nagova University

09P-25 Carbon Layer Formation on Boron Nitride via a Plasma in Hydroquinone Solution

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09P-26 Measurement of RONS Concentration in Plasma-Irradiated Artificial Seawater

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O9P-27 Specific Killing Effects of Plasma Activated Medium toward Human Melanoma Cancer Cell (A375) and Human Foreskin Fibroblasts (HFF)

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O9P-28 Dependence of Depth in Liquid Irradiated with Nitric-Oxide Radicals on Proliferation of Fibroblast Cells

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09P-29 Spatio-Temporal Distribution Measurement of Active Species in Plasma-Activated

Solution

Hiromi Yamamoto and Masafumi Ito

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09P-34 Design of 33GHz CMOS Transmitter with Gate-Leakage Oscillator Based

Temperature Sensor for Non-Invasive Continuous Blood Glucose Monitoring

Takuya Tsujimura, Guowei Chen, Yuma Hayashi, Sora Kato and Kiichi Niitsu

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09P-35 Analysis of Hydrogen Recycling Process on Carbon Material by Molecular Dynamics

Simulation and Attempt at development of its Deep Learning Model

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